

01/16/02

J1044 U.S. PRO

01-22-02

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Docket No. AMAT
422.05.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231Re: Inventor(s): Ling Chen and Wei Cao
Title: METHOD FOR GROWING THIN FILMS BY CATALYTIC ENHANCEMENT

Transmitted herewith is the patent application identified above, including:

☒ Specification, claims and abstract, totaling 15 pages.☐ Drawings totaling pages, Formal Informal.☒ Unsigned Declaration and Power of Attorney.☐ Assignment of the invention to Applied Materials, Inc.☐ Assignment Recordation Cover Sheet☐ Information Disclosure Statement (37 CFR 1.98)J1044 U.S. PRO
10/050654
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FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	20--	-20 =	0	X\$18.00	\$000.00
Independent Claims	3--	-3 =	0	X\$84.00	\$000.00
Basic Filing Fee				\$740.00	\$740.00
TOTAL FEES					\$740.00

☐ The Commissioner is hereby authorized to charge \$000000000 to Deposit Account No. 04-0822.☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-0822. A duplicate copy of this transmittal is enclosed.☒ Please address all future correspondence to:PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Patent Application, Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No. E1 902870772USDate of Deposit: January 16, 2002Signature Donald R. McKenna

Respectfully submitted,

Donald R. McKennaDonald R. McKenna
Registration No. 44,922